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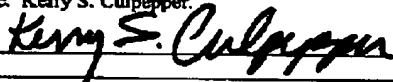
OCT 02 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: HIMI et al.	Atty. Dkt.: 01-100-DIV
Serial No.: 10/716,606	Art Unit: 2813
Filed: 11/20/2003	Examiner: Thanhha S. PHAM
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR SUBSTRATE	

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: 2 October 2006

<b>CERTIFICATE OF FACSIMILE TRANSMISSION</b>
I hereby certify that this correspondence is being facsimile transmitted to the USPTO (Fax. No. 571-273-8300) on 2 October 2006
Typed Name: Kerry S. Culpepper
Signature: 

**REPLY UNDER 37 CFR 1.116**

Sir:

In response to the office action mailed 2 June 2006, please amend the application as follows:

Remarks begin on page 2 of this paper.